

OCT 26 2004

10-28-04

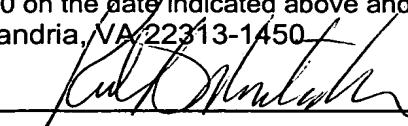
Ifw



EXPRESS MAIL No.: EV 302 914 914 US

Deposited: October 26, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service Express mail under 37 CFR 1.10 on the date indicated above and is addressed to: Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450


/ Ruth Montalvo Date: 10/26/04

Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. GK-OEH-178 / 500814.20080

Applicant(s): Duc Chinc TRAN and Juergen KLEINSCHMIDT

Application No.: 10/784,438

Examiner:

Filed: February 23, 2004

Group: 1763

For: ARRANGEMENT FOR DEBRIS REDUCTION IN A RADIATION SOURCE
BASED ON A PLASMA

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SECOND INFORMATION DISCLOSURE STATEMENT

SIR:

Applicant herewith submits this Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§ 1.97 and 1.98 and hereby makes of record the following references listed below

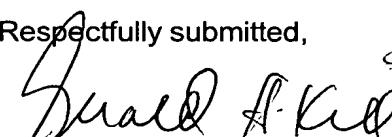
	Document Number	Date	Name and/or Country	English Translation
AA	6,285,737	09/04/2001	Sweatt, et al.	
AB	2003/0020890	01/30/2003	Ogushi, et al.	
AL	WO 02/27406	04/04/2002	WIPO	
AM	101 36 620	02/06/2003	Germany	Abstract only
AN	101 28 284	02/27/2003	Germany	Abstract only

Accompanying this Information Disclosure Statement is form PTO-1449 and copies of the foreign references including 2 English Abstracts.

Complete copies of the US references are not being submitted, since this application is filed after June 30, 2003. Only cover page of the US references are enclosed.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,



Gerald H. Kiel - Reg. No. 25,116
Reed Smith LLP
599 Lexington Avenue
New York, NY 10022-7650

GHK:ram
10/26/04
Tel. (212) 521-5400

Enclosures:
PTO-1449 w/3 Foreign documents,
2 English Abstracts & 2 cover pages



(2nd)
LIST OF PRIOR ART CITED BY APPLICANT
 (Filed on October 26, 2004)

Docket No. 5K-OEH-178 / 500814.20080

Applicant(s): Duc Chinc TRAN and Juergen KLEINSCHMIDT

Application No. 10/784,438

Group: 1763

Filed: February 23, 2004

Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	6,285,737	09/04/2001	Sweatt, et al.			
	AB	2003/0020890	01/30/2003	Ogushi, et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES	NO
	AL	WO 02/27406	04/04/2002	WIPO				
	AM	101 36 620	02/06/2003	Germany			Abstract only	
	AN	101 28 284	02/27/2003	Germany			Abstract only	
	AO							
	AP							
	AQ							
	AR							
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AV	
AW	
AX	
AY	
AZ	

Examiner:	Date:
-----------	-------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.